

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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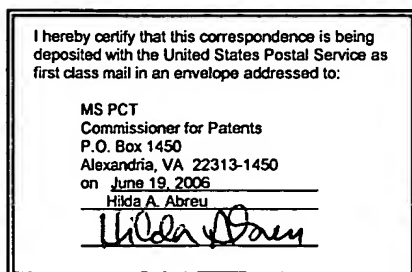
For : METHOD FOR MEASURING A SURFACE PLASMON
RESONANCE AND NOBLE METAL COMPOUND
USED FOR THE SAME

MS PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SECOND INFORMATION DISCLOSURE STATEMENT

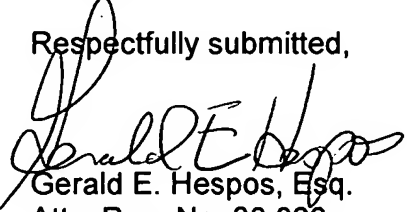
Sir:

This Information Disclosure Statement includes a copy of Form PTO-1449 that identifies two nonpatent publications. Copies of the publications are attached as well. These publications were identified in the International Search Report that was submitted concurrently with the entry of the U.S. National Phase of PCT/JP2004/015347. The relevancy of these documents is noted on the International Search Report. The Examiner is requested to consider these references during the examination and to make the references of record.



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Respectfully submitted,



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